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Practitioner's Docket No. MI22-2391

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Werner Juengling

Application No.: 10/678,513

Filed: 10/03/03

Group No.: 2823

Examiner: B. Kebede

For: Semiconductor Processing Methods of Forming a Contact Opening to a Conductive Line and Methods of Forming Substrate Active Area Source/Drain Regions

Commissioner for Patents Washington, D.C. 20231

CERTIFICATION OF FACSIMILE TRANSMISSION

I hereby certify that the following papers are being facsimile transmitted to the Patent and Trademark Office at (703) 872-9306 on the date shown below:

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Supplemental Information Disclosure Statement
PTO-Form 1449

2/10/05 Date Robin Saldivia

Signature

PLEASE CHARGE DEPOSIT ACCOUNT 23-0925 (Wells St. John P.S.) \$180.00 for this Supplemental IDS.

(Certification of Facsimile Transmission-page 1 of 1)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No	10/678,513
Filing Date	October 3, 2003
Inventor	Werner Juengling
Assignee	Micron Technology, Inc.
	2812
Examiner	B. Kebede
	Ml22-2391
	021567

Title: Semiconductor Processing Methods of Forming a Contact Opening to a Conductive Line and Methods of Forming Substrate Active Area Source/Drain Regions

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

References –See Attached Form PTO-1449

The attached Form PTO-1449 is submitted in compliance with 37 C.F.R. §§ 1.56. Pursuant to Federal Register Vol. 69, No. 182, pg. 56542 (September 21, 2004), no copies of any cited U.S. patents or U.S. published applications are included herewith. Copies of all other cited art references are attached. No admission is made regarding whether all the submitted references are prior art.

Citation of these references is respectfully requested.

Respectfully submitted,

Dated: 2-/0-05

By:

Reg. No. 40,045

Sheet 1 of 1

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U.S. PATENT DOCUMENTS											
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